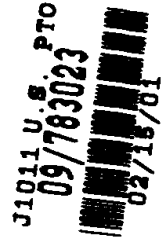


5-1-
PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:)
Yoshiaki FUKUZUMI, *et al.*)
Serial No.: TBA) Examiner: TBA
Filed: February 15, 2001) Docket No. 01701.00059



For: SEMICONDUCTOR DEVICE USING FUSE/ANTI-FUSE SYSTEM AND METHOD
OF MANUFACTURING THE SAME

INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

Pursuant to 37 C.F.R. §1.56 and in compliance with 37 C.F.R. §1.97, Applicants submit herewith a Form PTO-1449 identifying information for consideration by the Examiner. A copy of each of the items of information is enclosed.

Applicants do not waive any rights to take appropriate action to establish patentability over the listed documents should they be applied as a reference against the claims of the present application.

Consideration of the cited information and making the same of record in the prosecution of the above-noted application are respectfully requested. Should the Patent and Trademark Office determine that a fee is required, please charge our Deposit Account No. 19-0733.

Respectfully submitted,

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